

**Search Notes**

Application No.

10/656,311

Examiner

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Applicant(s)

CHEN ET AL.

Art Unit

3729

**SEARCHED**

Class	Subclass	Date	Examiner
29	603.07 603.11 603.13- 603.16	9/21/2004	PK
	603.18 605		
	606		
360	121-126	9/21/2004	PK
	317		
427	127 128	9/21/2004	PK
216	65		
204	192.15		
205	119 122		
451	5 41		

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Reviewed Parent Application 09/617,791 (US PAT. 6,618,223)	9/21/2004	PK
Text Search EAST/NPL (IEEE)	9/22/2004	PK
Updated Text Search EAST	6/1/2005	PK